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3742

SEARCHED			
Class	Subclass	Date	Examiner
219	634	Induction	
	730	Microwave	
	759	Microwave	
	<del>722</del>	<del>Heat</del>	
ing Apparatus			
118	724	Heating or	
	725	Substrate	
	722	Heating m	
	728	Work supp	
	729	Molding	
	733	Chambers	
	730	Rotary	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

	DATE	EXMR
JPO, EPO Derwent USPTO/East		
Co-pending with 10/538,529		
371 of PCT/IT02/00773 12-10-2002		
I.O.S. 6-10-2006 <sup>10</sup> U.S. Patents		
Inventors Maccalli @ Korling Valente @ Krippa @ Prefr Searched		
Susceptor for Substrates or Wafers for Induction Heating Search notes attached		